



RE 02  
9/12/98  
GP- 2816

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the application of:

John Mark Anthony *et al.*  
Serial No.: 09/116,138  
Filed: 07/15/98  
For: High Permittivity Silicate Gate Dielectric

Docket: TI-24953  
Examiner: TBD  
Art Unit: 2816

#5  
4/27/98  
M. Fudge

## INFORMATION DISCLOSURE STATEMENT

September 9, 1998

Assistant Commissioner For Patents  
Washington, D. C. 20231

MAILING CERTIFICATE UNDER 37 CFR § 1.8	
I hereby certify that this correspondence is being deposited with the	
United States Postal Service as first class mail in an envelope addressed	
to: Assistant Commissioner for Patents, Washington, DC 20231 on	
<u>September 10</u> , 1998.	
Sue Short	

Examiner:

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed PTO-1449.

Copies of reference(s) AP and AQ are not enclosed as these are pending applications. Applicants believe that no fee is due. However, the Commissioner is authorized to charge any necessary fee to Deposit Account 20-0668.

Respectfully submitted,

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